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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Attorney Docket No. 2006_1372A
Norikazu SUGAYA et al. : **Confirmation No. 1096**
Serial No. 10/590,503 : Group Art Unit 1792
Filed August 24, 2006 : Examiner William P. Fletcher
METHOD OF PREVENTING ELUTION OF : **Mail Stop: AMENDMENT**
NICKEL FROM WETTED INSTRUMENT
OF COPPER ALLOY, PROTECTIVE FILM
FORMATION AGENT FOR PREVENTING
ELUTION OF NICKEL AND DETERGENT
FOR PREVENTING ELUTION OF NICKEL

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated October 14, 2009 in which restriction has been required, Applicants hereby elect the invention identified as Group I, claims 1-9, drawn to a method.

Favorable action on the merits is now requested.

Respectfully submitted,

Norikazu SUGAYA et al.

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